Form PTO-14/9
INFORMATION DISCLOSURE CHATION
IN AN APPLICATION
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APR 2 2 2002

Docket Number (Optional) AMY-002.01 (21424-201)

Application Number 10/079,985

Applicant

Hiro Tamura, et al.

Filing Date February 21, 2002

Group Art Unit

		V VbK -		bruary 21, 2002 J.S. PATENT DOCUMENTS			
EXAMINER INITIAL	D	OCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
·MAG	AA	US 6,327,855 B1	12/11/01	Hill et al.	60	528	
ut	АВ	US 6,324,748 B1	12/04/01	Dhuler et al.	29	622	
M	AC	US 6,308,631 B1	10/30/01	Smith et al.	102	254	
MX	AD	US 6,300,619 B1	10/09/01	Aksyuk et al.	250	216	
M	AE	US 6,285,504 B1	09/04/01	Diemeer	359	578	-
MA	AF	US 6,265,239 B1	07/24/01	Aksyuk et al.	438	52	
MA	AG	US 6,262,463 B1	07/17/01	Miu et al.	257	414	
MA	АН	US 6,255,757 B1	07/03/01	Dhuler et al.	310	307	
MX	AI	US 6,246,826 B1	06/12/01	O'Keefe et al.	385	140	
MH	AJ	US 6,222,954 B1	04/24/01	Riza	385	18	
MIL	AK	US 6,171,886 B1	01/09/01	Ghosh et al.	438	73	
MH	AL	US 6,173,105 B1	01/09/01	Aksyuk et al.	385	140	
Mit	AM	US 6,085,016	07/04/00	Espindola et al.	385	140	
,41	AN	US 6,166,478	12/26/00	Yi et al.	310	328	
MU	AO	US 6,137,941	10/24/00	Robinson	385	140	
MA	AP	US 5,994,816	11/30/99	Dhuler et al.	310	307	
M	AQ	US 5,909,078	06/01/99	Wood et al.	310	307	
NH	AR	US 5,778,513	07/14/98	Miu et al	29	602.1	
M	AS	US 5,629,918	05/13/97	Ho et al.	369	112	
UK	AT	US 6,275,320 B1	08/14/01	Dhuler et al.	359	237	
SH	AU	US 6,163,643	12/19/00	Bergmann et al.	385	140	
MH	AV	US 6,087,743	07/11/00	Guckel et al.	310	40	
M	AW	US 5,929,542	07/27/99	Ohnstein et al.	310	40	
MM	AX	US 5,808,384	09/15/98	Tabat et al.	310	40	
141	AY	US 5,644,177	07/01/97	Guckel et al.	310	40	
MK	AZ	US 5,327,033	07/05/94	Guckel et al.	310	40	
MI	ВА	US 5,206,983	05/04/93	Guckel et al.	29	598	
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INFORMATION DISCLOSURE OF ATION			Docket Number (Optional) AMY-002.01 (21424-201)	Application Number					
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		( Arr · · · · · · · · · · · · · · · · · ·	Filing Date	Group Art Unit					
		A CHART DO	February 21, 2002						
.1		Bhansali et al.: "Prototype Feedback	G-Controlled Ridirectional Actuation System 6	(Including Author, Title, Date, Pertinent Pages Etc.) or MEMS Applications", Journal of Microelectromechanical					
MH	B	B 3,566,113, 7 (2). 243-231 (June 2000)							
MA	В	C	ide More Speed and Utility", Laser Focus Wor						
My	ВІ	Christenson and Guckel; "An Electromagnetic Micro Dynamometer", 1995 IEEE MEMS Proceedings, Amsterdam, the Netherlands, pp. 386-391, 29 Jan- 2 February, 1995.							
MI	BI	25 26 (1555)		nternational Symposium on Test & Measurement, ISTM, PP.					
M	BF	( ( ( ( ( ( ( ( ( ( ( ( ( ( ( ( ( ( ( (		Actuator Workshop, Hilton Head, South Carolina, pp. 49-52					
MH	BG	Guckel et al.; "Design and Testing of International Conference on Solid-Sta	F Planar Magnetic Micromotors Fabricated by late Sensors and Actuators, Yokohama, Japan, p	Deep X-Ray Lithography and Electroplating", The 7 <sup>th</sup> op.76-79, (June 7-10, 1993)					
MH	ВН	Guckel et al., "Fabrication and Testin	ng of the Planar Magnetic Micromotor", J. Mic	romech. Microeng. 1: 135-138, (1991)					
MH	ВІ	Guckel et al.; "Electromagnetic, Spring Constrained Linear Actuator with Large Throw", Actuator'94, pp. 52-55, (Bremen, Germany June 15-17, 1994)							
MH	ВЈ		ctuators Via Deep X-Ray Lithography", SPIE						
MK	BK	Guckel et al.; "Processing and Design Considerations for High Force Output- Large Throw Electrostatics, Linear Microactuators", Actuator 94, Bremen, Germany pp. 105-108, (15-17 June 1994) (Abstract)							
MH	BL	H. Guckel and University of Wisconsin, Madison, "Photograph of Actuator," online, retrieved on February 1, 2002 from URL http://mems.engr.wisc.edu/images/linear/intgrated_coil.jpg.							
MH	ВМ		(Abstract)	", International Symposium on Microsystems, Intelligent					
MH	BN	2, (September 2		Polyimide-Based Hinges", Journal of Microelectromechanical					
UH	ВО	Ohnstein et al.; "Tunable IR Filters with Integral Electromagnetic Actuators", Solid-State Sensor and Actuator Workshop, Hilton Head, South Carolina, pp. 196-199, (June 2-6, 1996)							
MH	ВР		00)	nection Concepts", Journal of Microelectromechanical					
MAT	BQ	Sadler et al.; "A New Electromagnetic Actuator Using Through-Hole Plating of Nickel/ Iron Permalloy", Electrochemical Society Proceedings volume 98(20): 377-388							

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INFORMATION DISCLOSURE CITATION IN'AN APPLICATION, (Use several sheets if necessary)			Docket Number (Optional)		Application Number	
			AMY-002.01 (21424-201)		10/079,985	
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		Ī	Filing Date		Group Art Unit	-
			February 21, 2002			
MH BR		O P E	ie 16-19, 1997)	itor", Transducers 97, Interi	national Conference on Solid-State Sensors and	d
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